



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Chung Wai Leung et al.
Assignee: Mosel Vitelic, Inc.
Title: Nonvolatile Memory Structures and Fabrication Methods
Application No.: 10/689,908 Filing Date: October 20, 2003
Examiner: Unknown Group Art Unit: Unknown
Docket No.: M-11467-2D US

San Jose, California
December 8, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 CFR § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are not enclosed as all documents were previously cited by or submitted to the Patent Office in prior applications relied upon for priority under 35 U.S.C. 120(37 C.F.R. § 1.98(d)). The prior application is U.S. Application No. 10/200,443, filed July 22, 2002.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be material to patentability as defined in § 1.56(b).

No fee is believed to be required. If a fee is required for this Information Disclosure Statement, please charge the fee to Deposit Account No. 50-2257. This paper is being submitted in duplicate.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 8, 2003.

Michael Shenker 12-8-03
Attorney for Applicant(s) Date of Signature

Respectfully submitted,

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U.S. Department of Commerce, Patent and Trademark Office						Atty Docket No.		Serial No.	
						M-11467-2D US		Unassigned	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT								Applicant(s)	
(Use several sheets if necessary)								Leung et al.	
								Filing Date	Group
								October 20, 2003	10/689,908
U.S. Patent Documents									
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	AA	5,427,966	27 Jun. 1995	Komori et al.					
	AB	5,484,741	16 Jan. 1996	Bergemont					
	AC	5,792,695	11 Aug. 1998	Ono et al.					
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)									
Examiner			Date Considered						
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>									